

CONTRACT AWARD NOTICE
RESULTS OF THE PROCUREMENT PROCEDURE
Supplies

Directive 2014/24/EU

SECTION I: CONTRACTING AUTHORITY

I.1) NAME AND ADDRESSES

Official name:

Universiteit Twente

National ID:

50130536

Postal address:

Drienerlolaan 5

Town:

Enschede

NUTS code:

NL

Postal code:

7522NB

Country:

NL

Contact person:

Camilio Delfgaauw

Telephone:

+31 534891512

E-mail:

c.delfgaauw@utwente.nl

Fax:

-

Internet address(es)

Main address:

<http://www.utwente.nl>

Address of the buyer profile:

<https://s2c.mercell.com/buyer/16033>

I.2) JOINT PROCUREMENT

-

I.4) TYPE OF THE CONTRACTING AUTHORITY

Body governed by public law

I.5) MAIN ACTIVITY

- Education

SECTION II: OBJECT

II.1) SCOPE OF THE PROCUREMENT

II.1.1) Title

System for Plasma-enhanced chemical vapor deposition (PECVD)

Reference number: EB-OUT 5934

II.1.2) CPV code(s)

Main code:

38000000 - Laboratoriuminstrumenten, optische en precisie-instrumenten (uitgezonderd brillen)

Supplementary code:

-

II.1.3) Type of contract

Supplies

II.1.4) Short description

The MESA+ Institute will invest in a two new systems for deposition of (doped) dielectric thin films to upgrade and reinforce their state-of-the-art thin film technology and processing capacity.

Applications

Low-temperature deposition of pinhole-free, low stress, conformal thin films.

Moderate-temperature deposition of low stress thin films.

II.1.6) Information about lots

This contract is divided into lots: no

II.1.7) Total value of the procurement (excluding VAT)

-

II.2) DESCRIPTION

II.2.1) Title

-

Lot No: -

II.2.2) Additional CPV code(s)

-

II.2.3) Place of performance

NUTS code:

NL NEDERLAND

Main site or place of performance:

-

II.2.4) Description of the procurement:

(nature and quantity of works, supplies or services or indication of needs and requirements)

The MESA+ Institute will invest in a two new systems for deposition of (doped) dielectric thin films to upgrade and reinforce their state-of-the-art thin film technology and processing capacity.

Applications

Low-temperature deposition of pinhole-free, low stress, conformal thin films.

Moderate-temperature deposition of low stress thin films.

II.2.5) Award criteria

Quality criterion

Name: Schedule of Requirements and wishes

Weighting: 8

Quality criterion

Name: Acceptance test

Weighting: 100

Cost criterion

Name: Price

Weighting: 47

II.2.11) Information about options

Options: no

II.2.13) Information about European Union funds

The procurement is related to a project and/or programme financed by European Union funds: no

II.2.14) Additional information:

-

SECTION IV: PROCEDURE

IV.1) DESCRIPTION

IV.1.1) Type of procedure

Open procedure

IV.1.3) Information about a framework agreement or a dynamic purchasing system

-

IV.1.6) Information about electronic auction

-

IV.1.8) Information about the Government Procurement Agreement (GPA)

The procurement is covered by the Government Procurement Agreement: no

IV.2) ADMINISTRATIVE INFORMATION

IV.2.1) Previous publication concerning this procedure

Notice number in the OJ S: 2023/S 112-351658

IV.2.8) Information about termination of dynamic purchasing system

-

IV.2.9) Information about termination of call for competition in the form of a prior information notice

-

SECTION V: AWARD OF CONTRACT

Contract No: -

Lot No: -

Title: -

A contract/lot is awarded: no

V.1) INFORMATION ON NON-AWARD

The contract/lot is not awarded

Other reasons (discontinuation of procedure)

SECTION VI: COMPLEMENTARY INFORMATION

VI.3) ADDITIONAL INFORMATION

-

VI.4) PROCEDURES FOR REVIEW

VI.4.1) Review body

Official name:

Rechtbank overijssel

Postal address:

-

Town:

Almelo

Postal code:

-

Country:

NL

E-mail:

-

Telephone:

-

Internet address:

-

Fax:

-

VI.4.2) Body responsible for mediation procedures

-

VI.4.3) Review procedure

Precise information on deadline(s) for review procedures:

-

VI.4.4) Service from which information about the review procedure may be obtained

-

VI.5) DATE OF DISPATCH OF THIS NOTICE

12/07/2023